

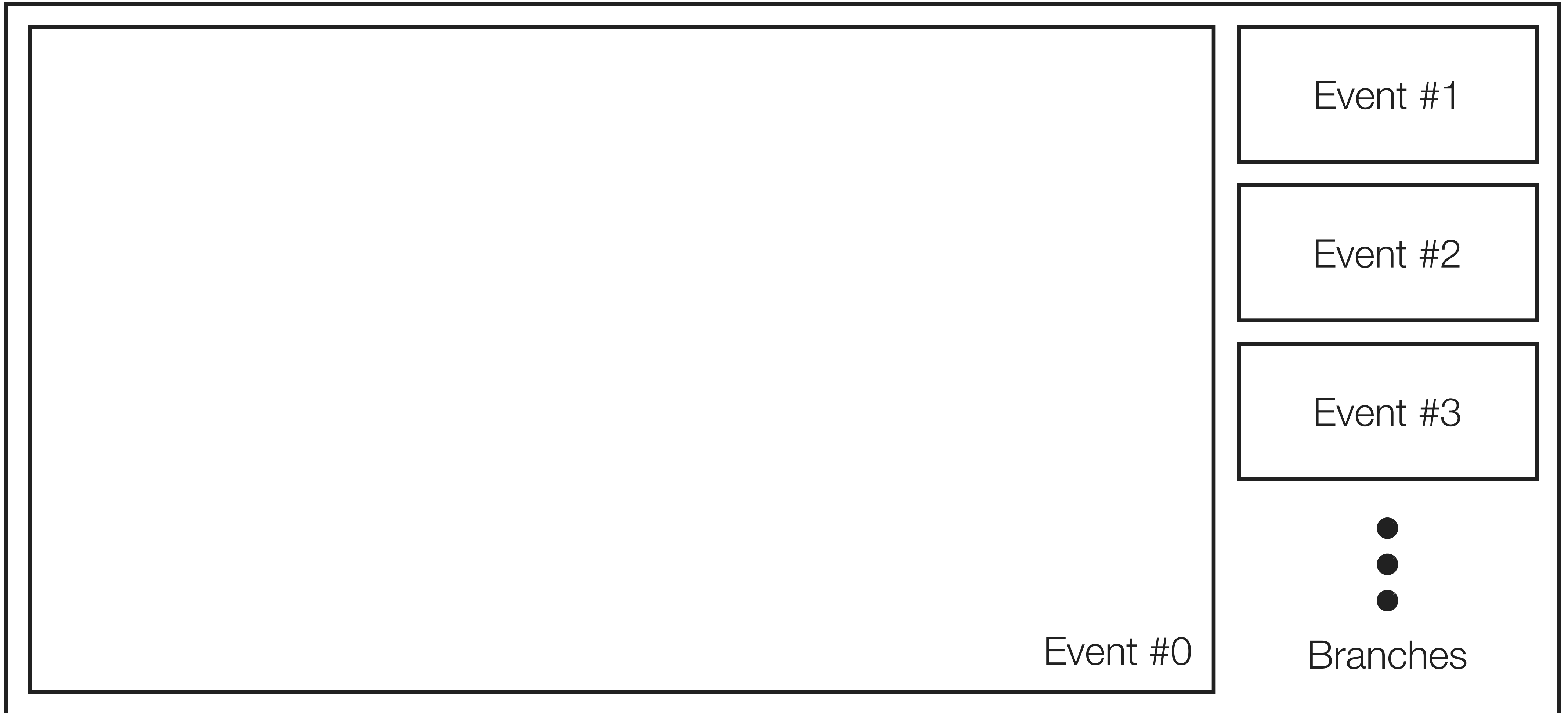
TPC Simulation

JungWoo Lee

Group Meeting, 2013.8.9

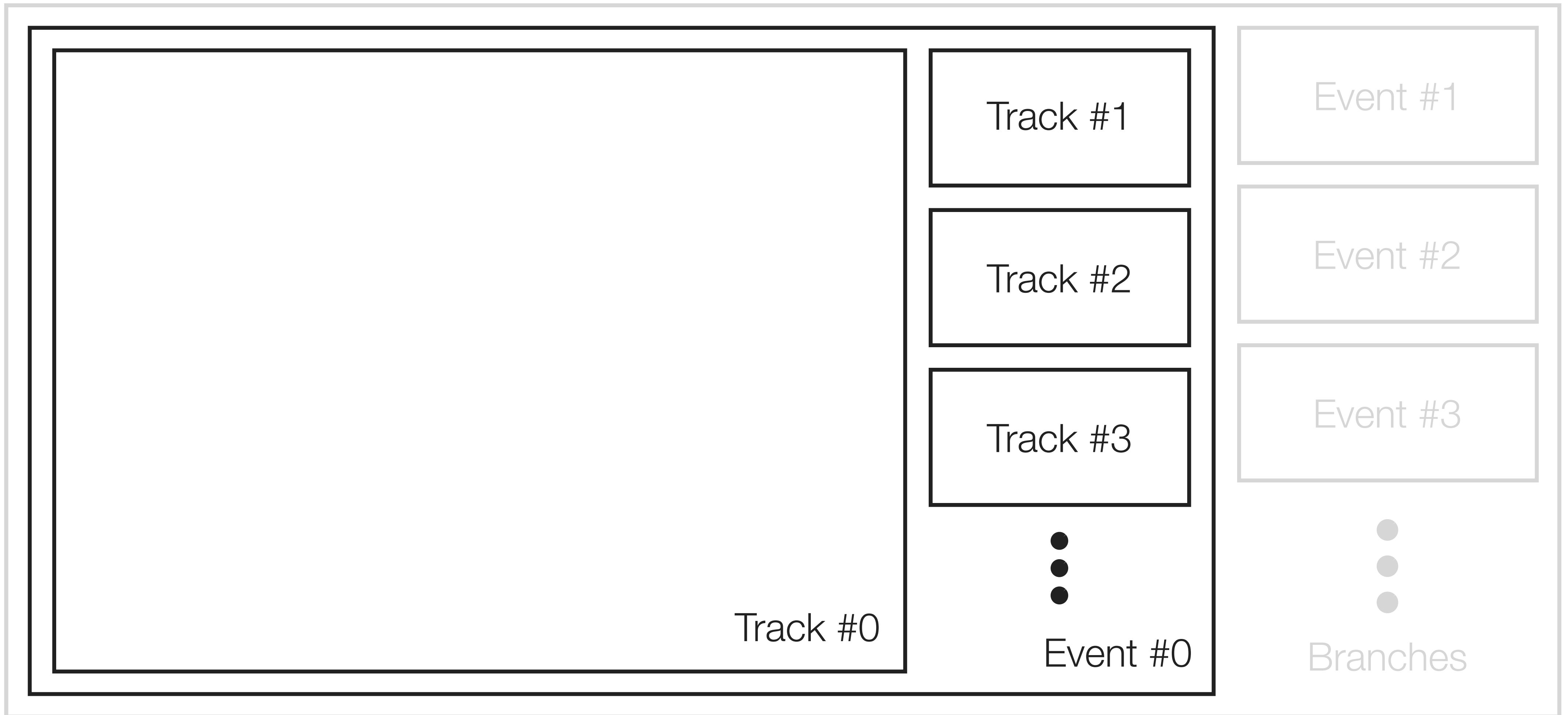
Digitized data

digitizedData.root



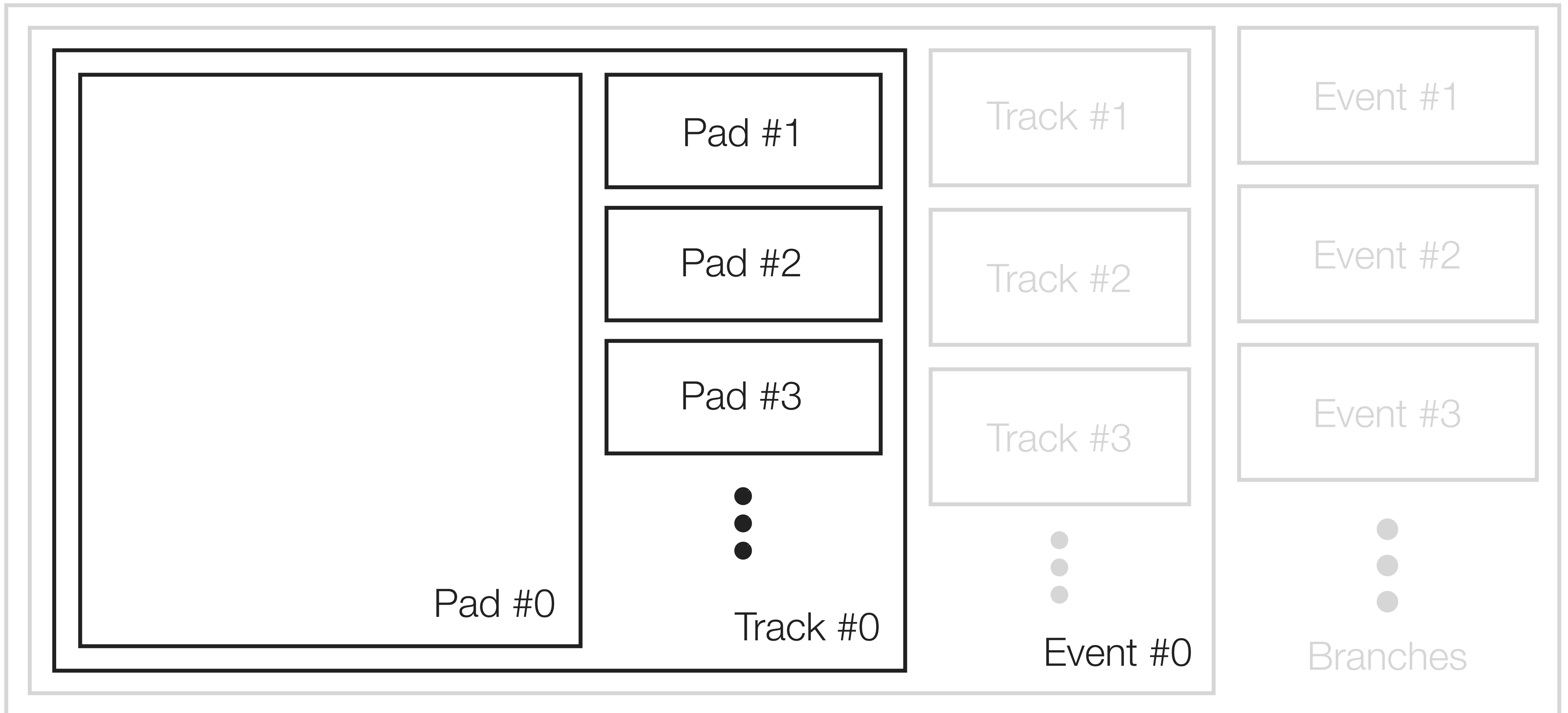
Digitized data

digitizedData.root



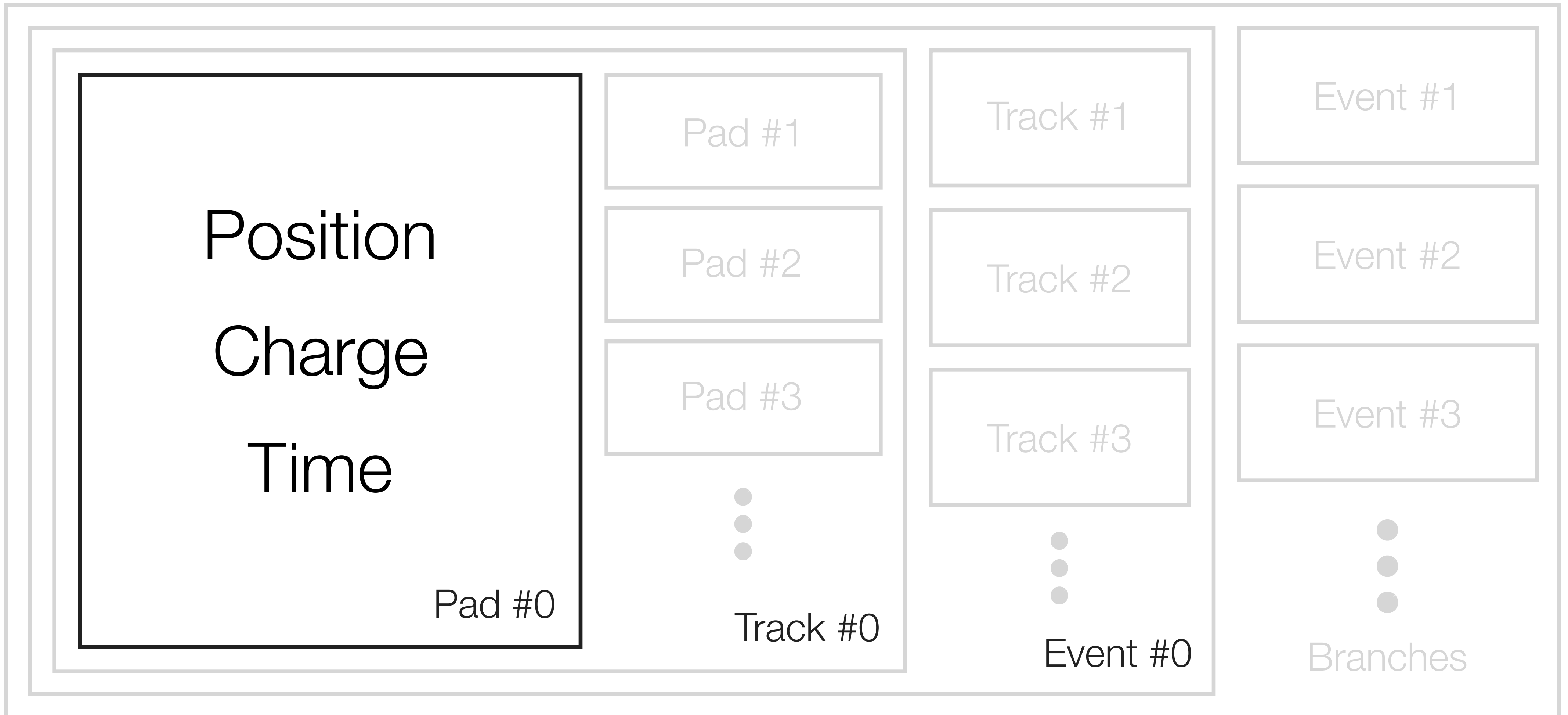
Digitized data

digitizedData.root



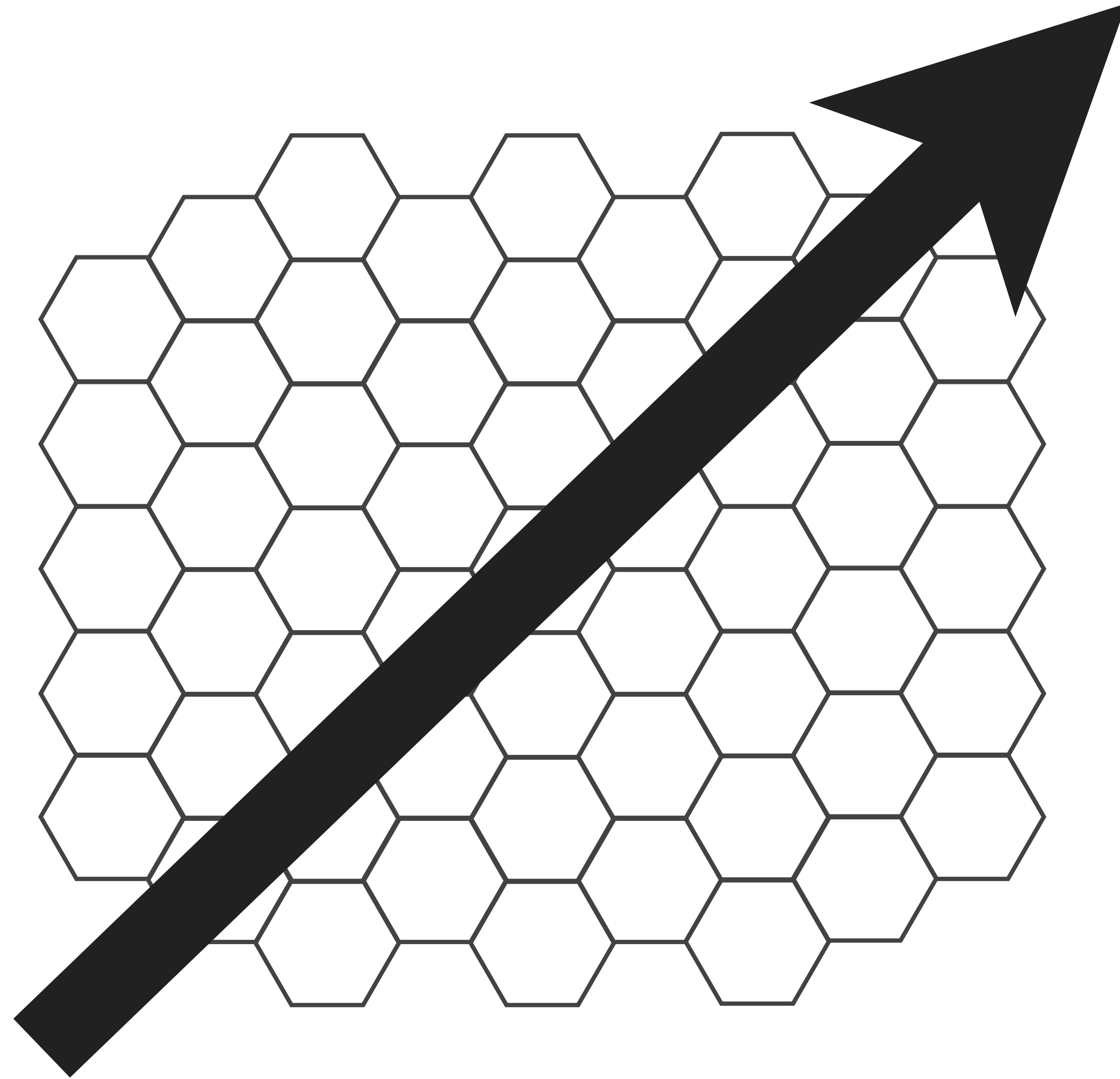
Digitized data

digitizedData.root



Clustering

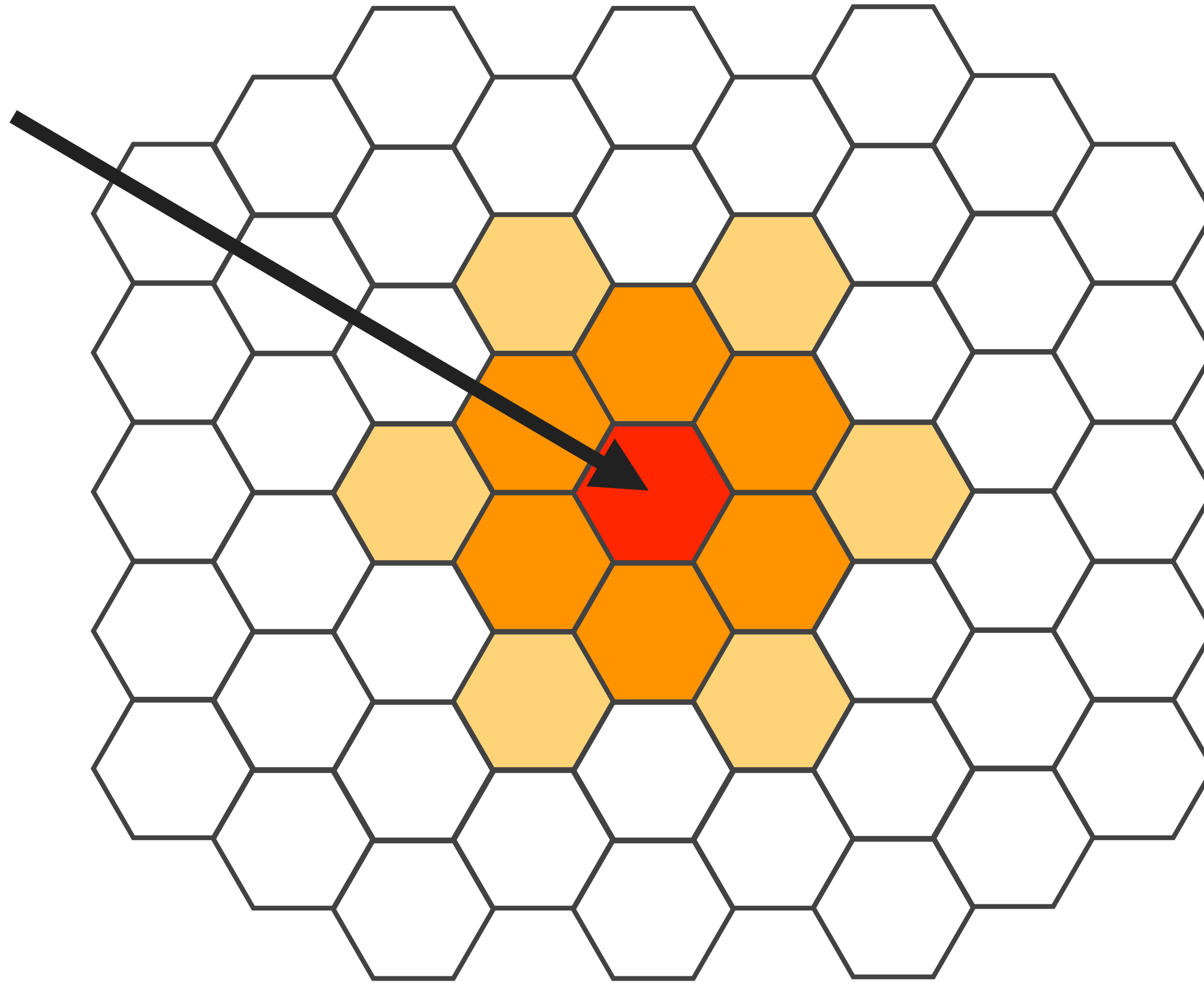
2D example



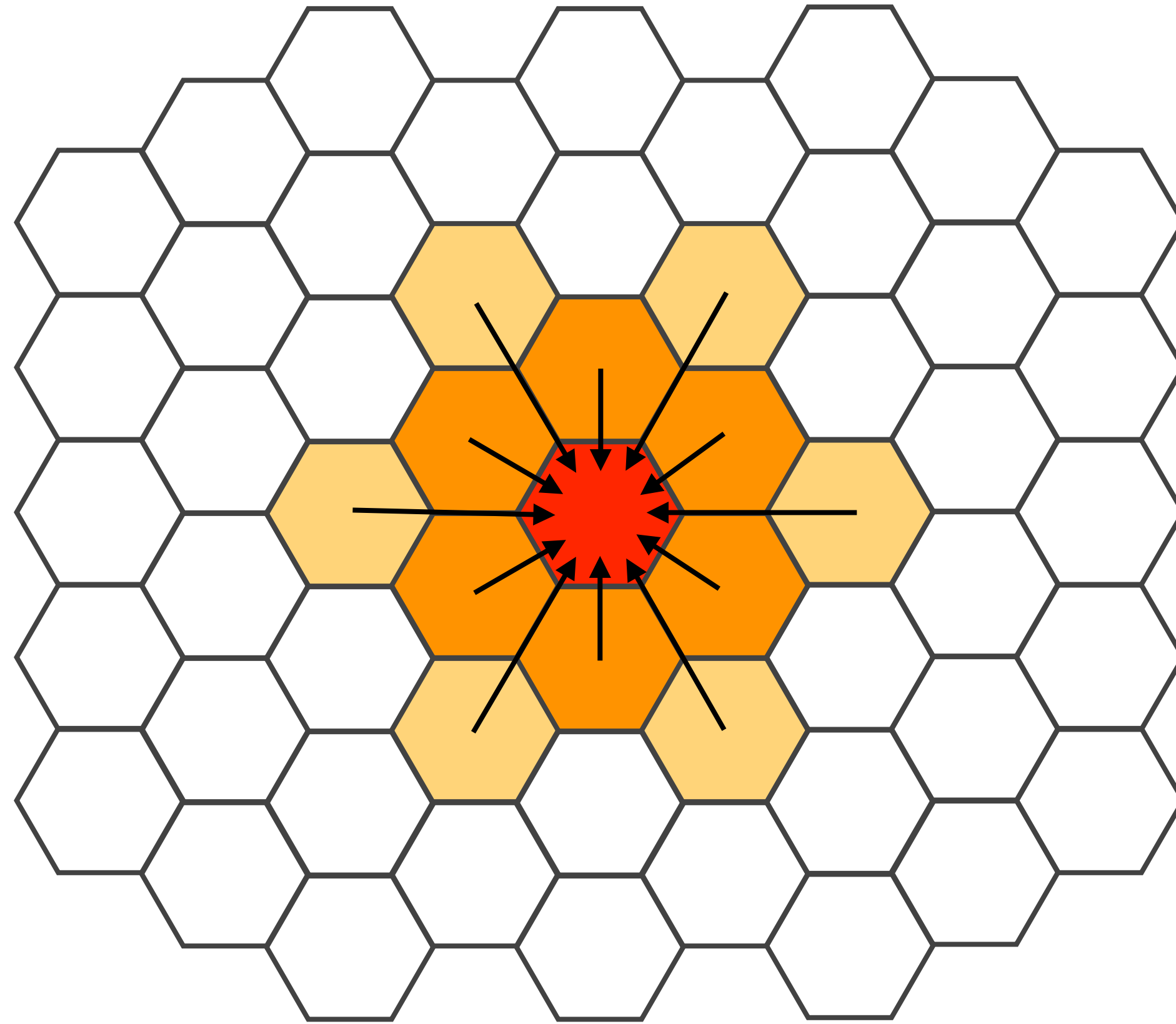
Track

Clustering

Maximum!

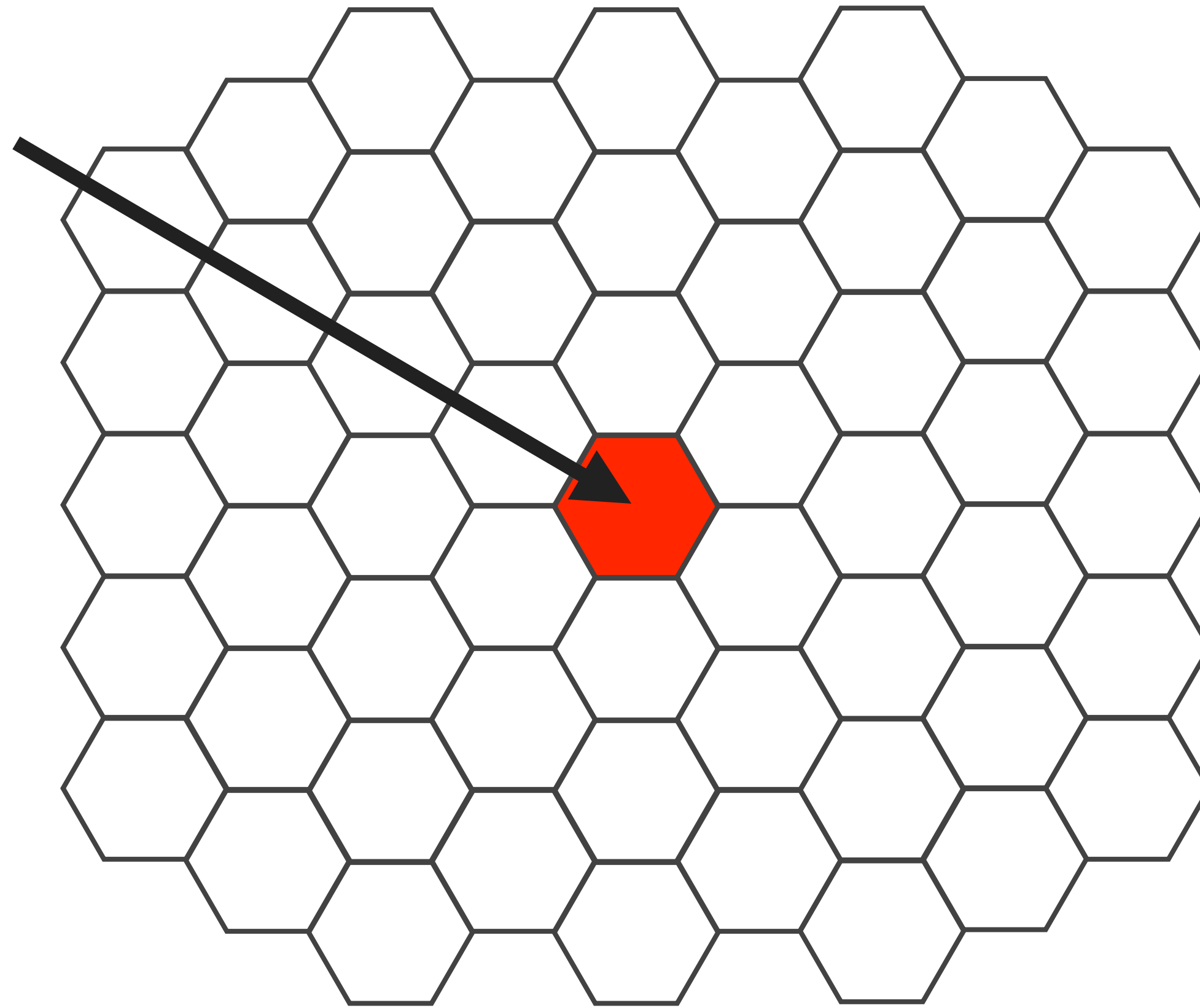


Clustering

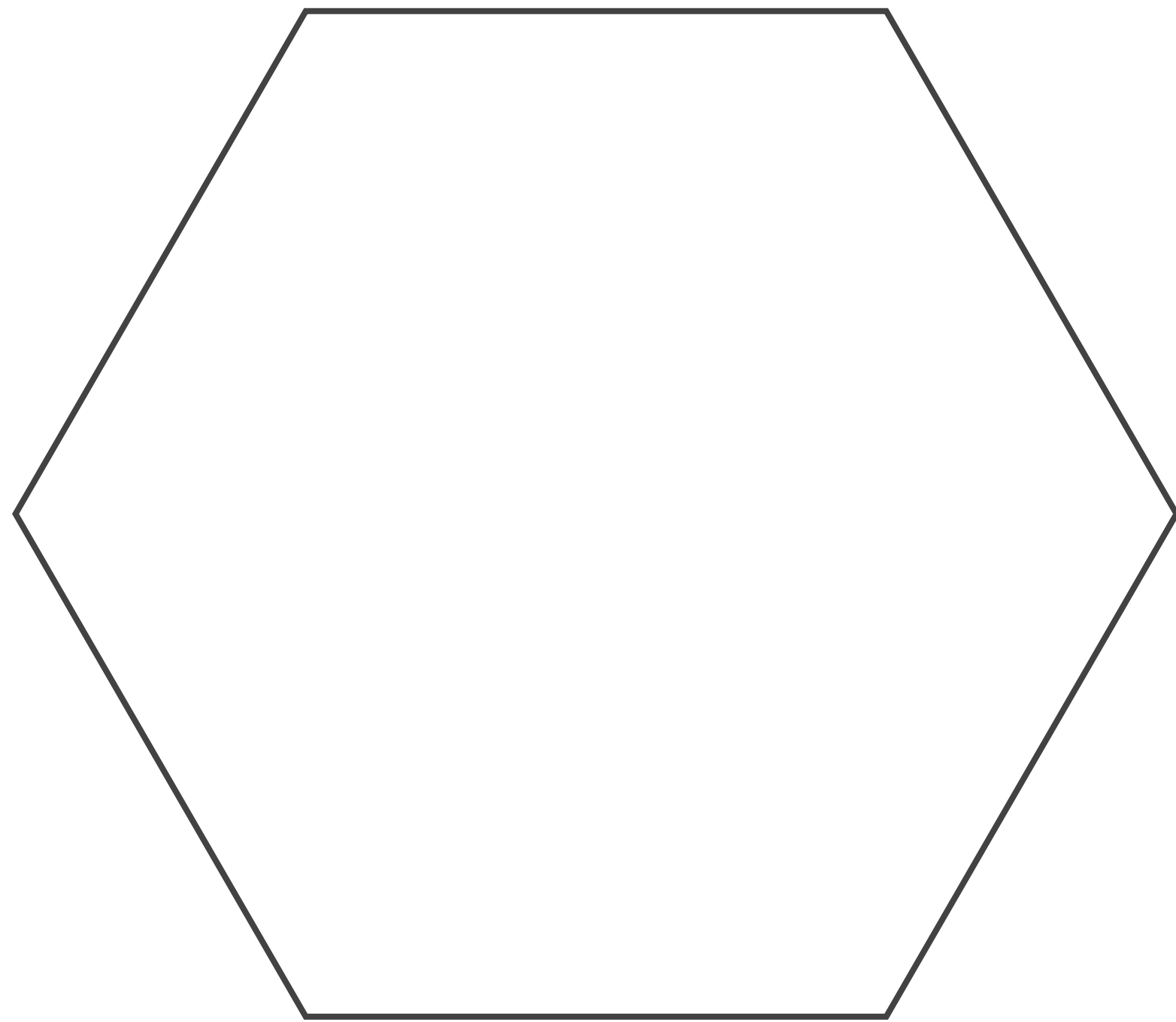


Clustering

Center of
charge



Pad mapping



Pad

1. Geometrical pad position

: (x, y)

2. Global bin number

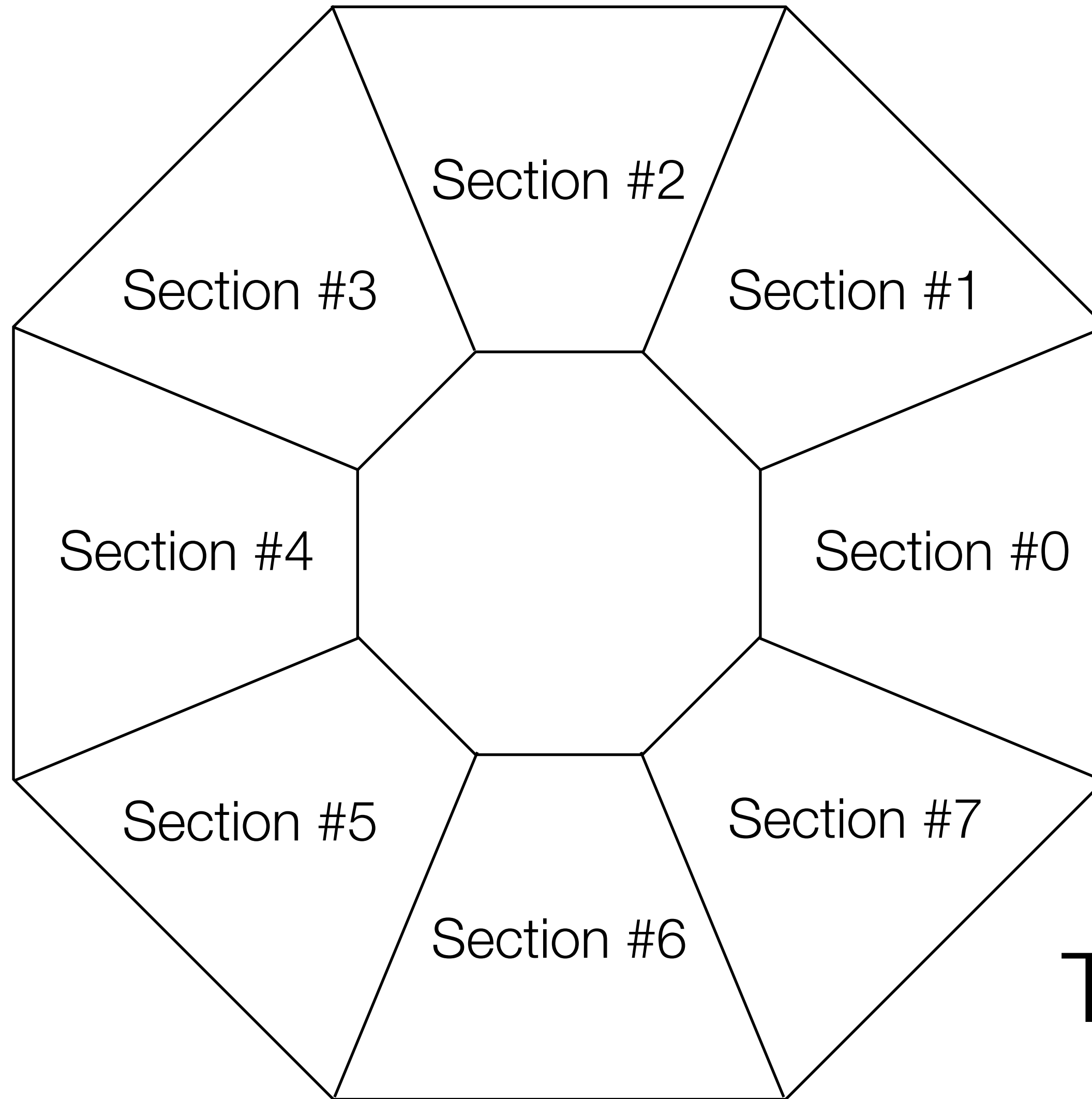
: Given when creating bin.

3. Pad ID

: (section, row, column)

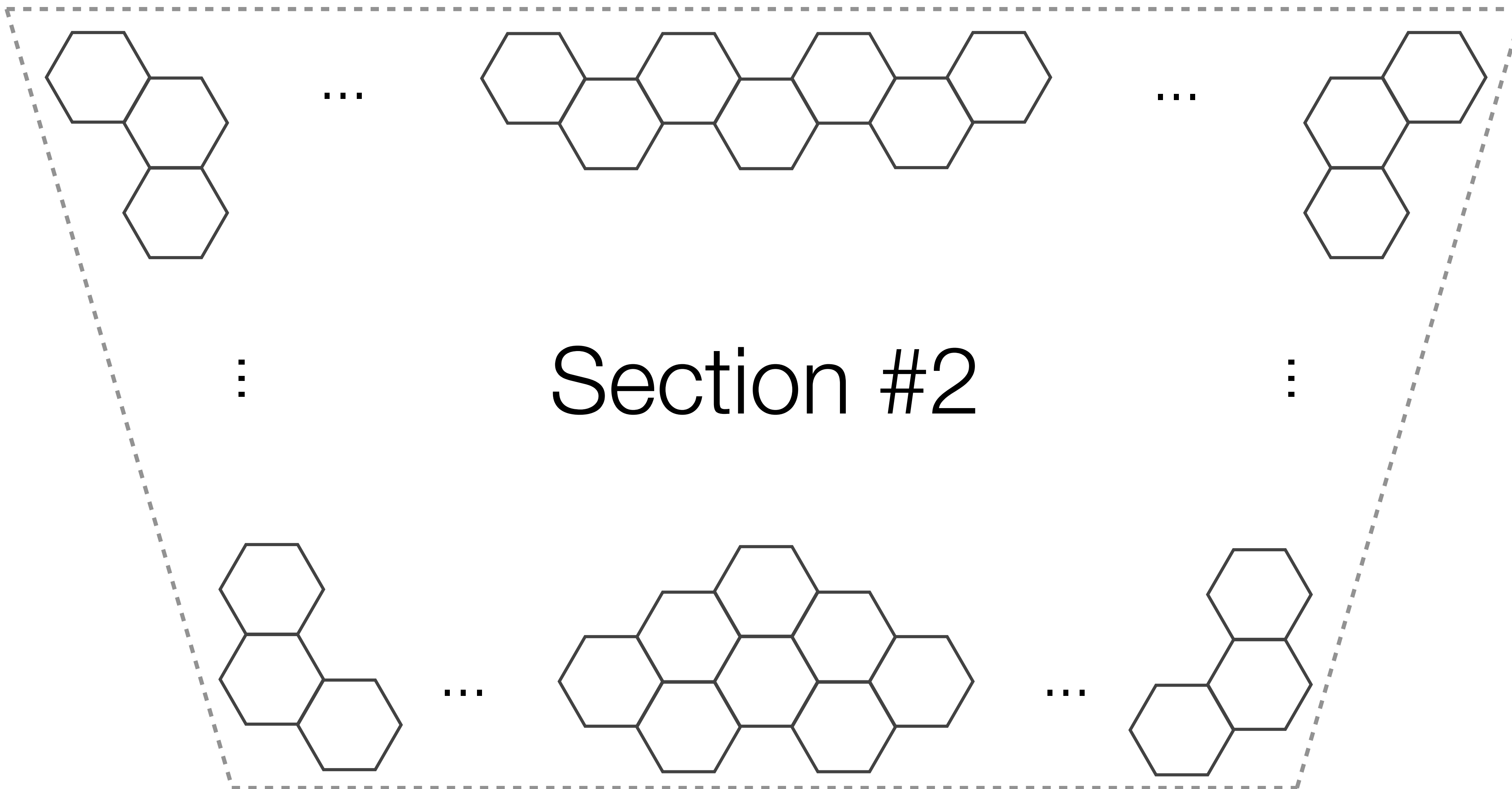
Given by me!

Pad mapping

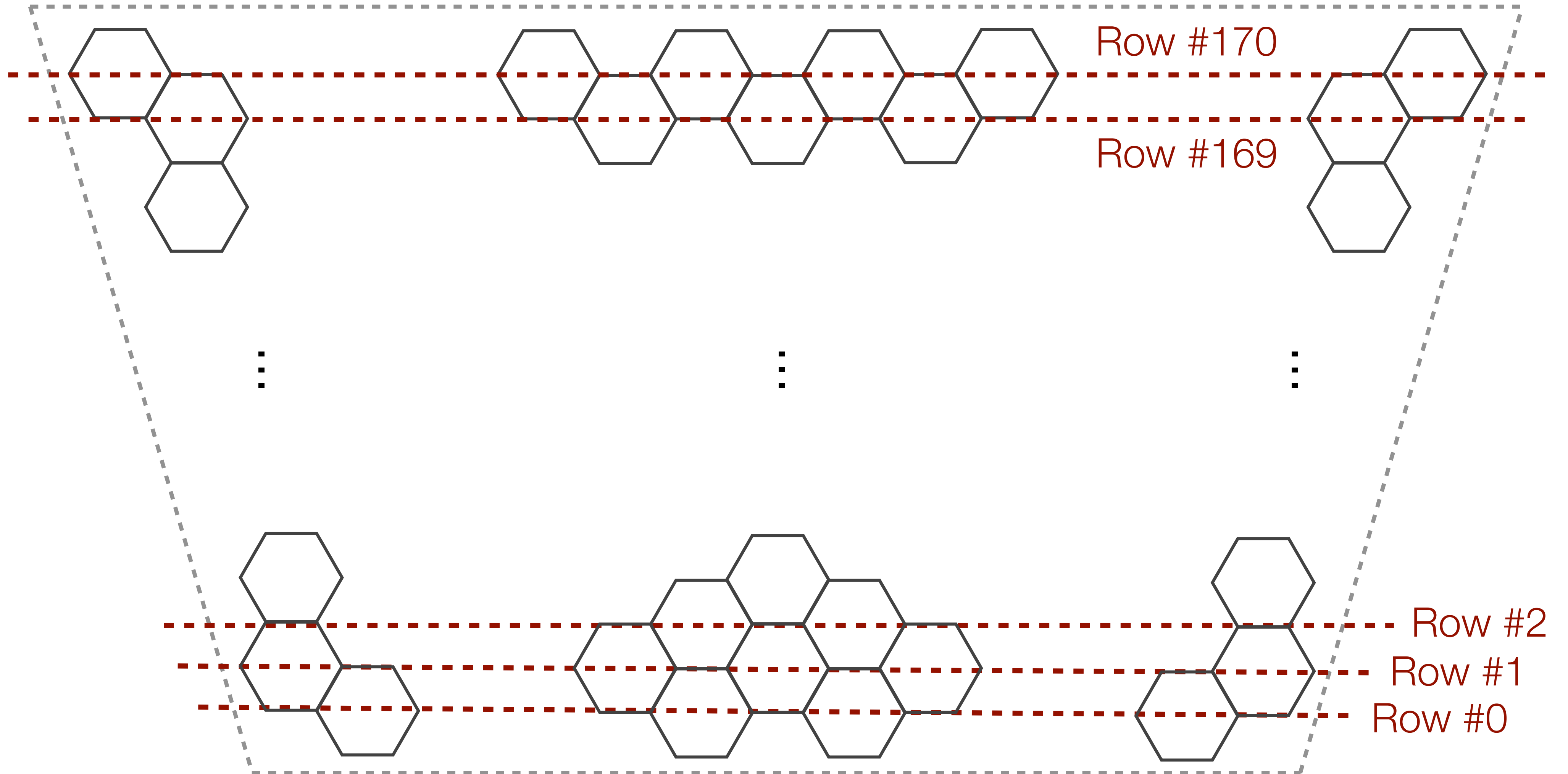


TPC Plane

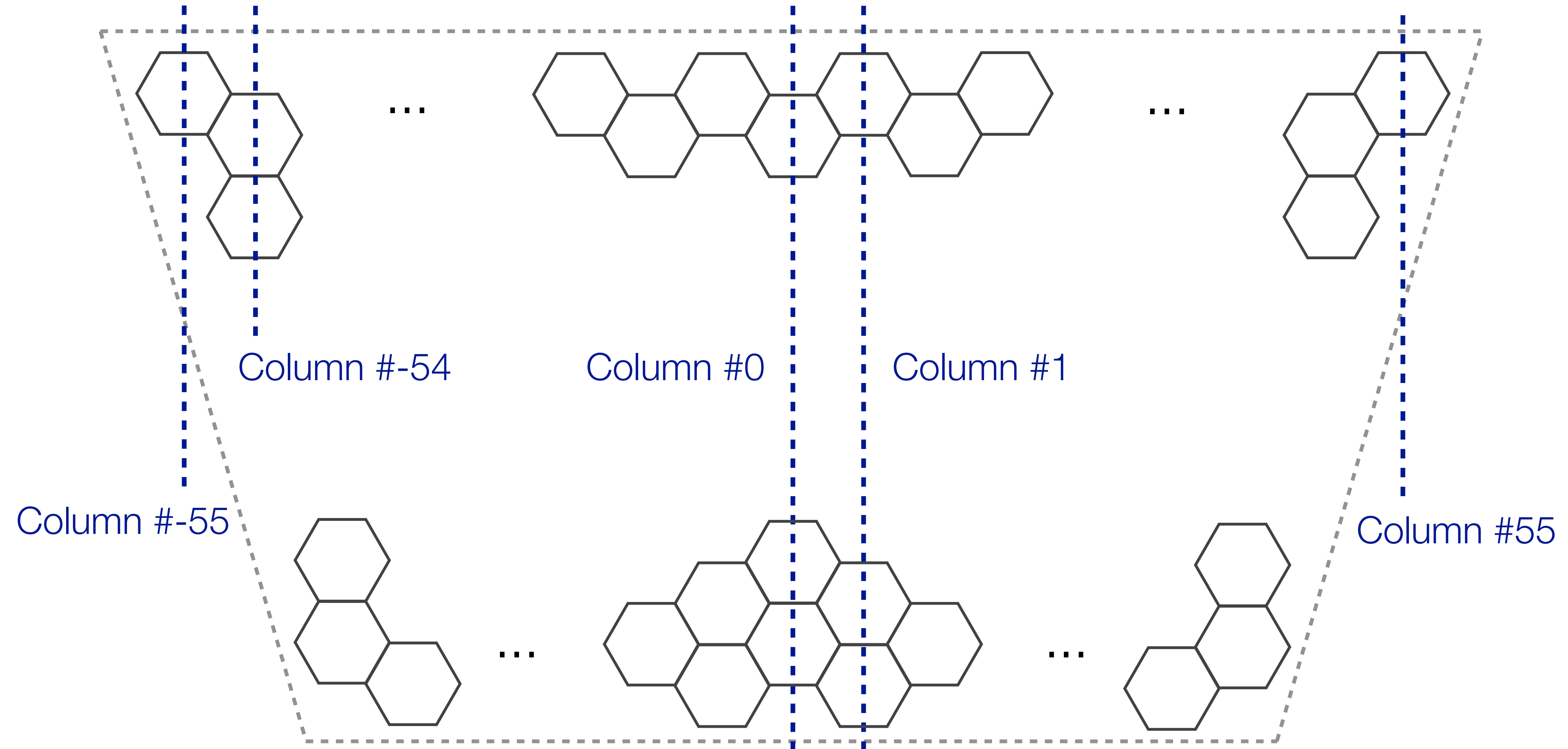
Pad mapping



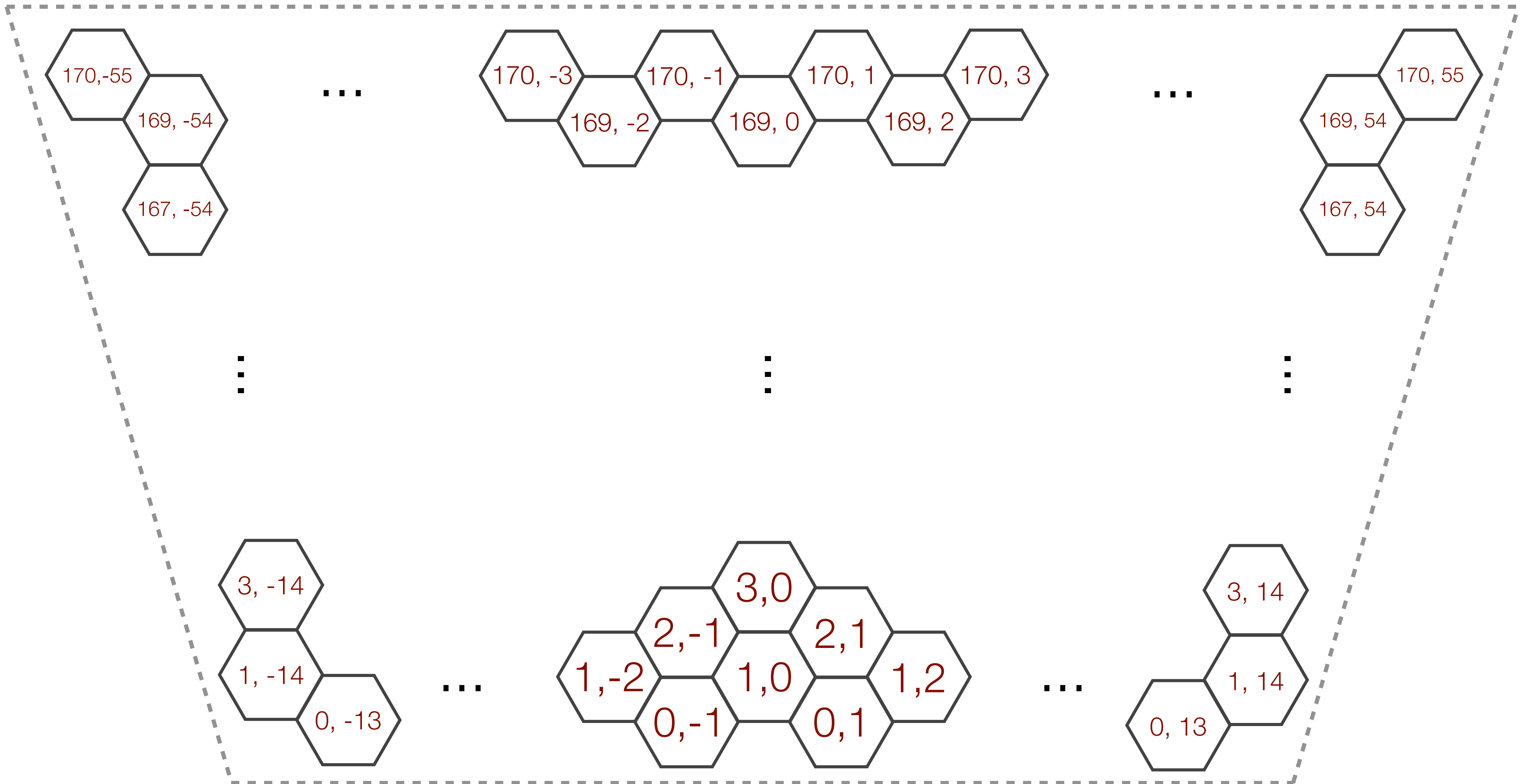
Pad mapping (2.5mm pad)



Pad mapping (2.5mm pad)

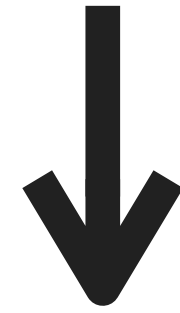


Pad mapping (2.5mm pad)

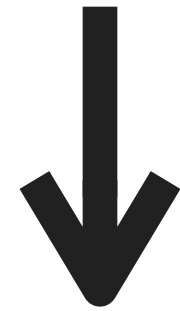


Summary

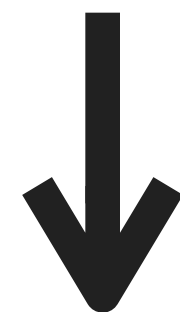
Pad mapping



Make digitized data file



Clustering in 3D



Kalman Filter

BACK UP

Geant4 simulation

ProductionCutsTable

: Low limit of 250 eV is mostly used for low energy physics.

Charge deposit in a pad

For one hit,

$$\begin{aligned} & (\text{Energy deposit}) / (\text{Mean ionization energy}) \times (\text{Gem gain}) \\ &= 0.0005 \text{ MeV} / (26.7 \times 10^{-6} \text{ MeV/e}) \times 100^3 \\ &= 2 \times 10^7 \text{ e} \end{aligned}$$

$$120 \text{ fC} = 7.5 \times 10^5 \text{ e}$$